

# Self-trapped beams for fabrication of optofluidic chips

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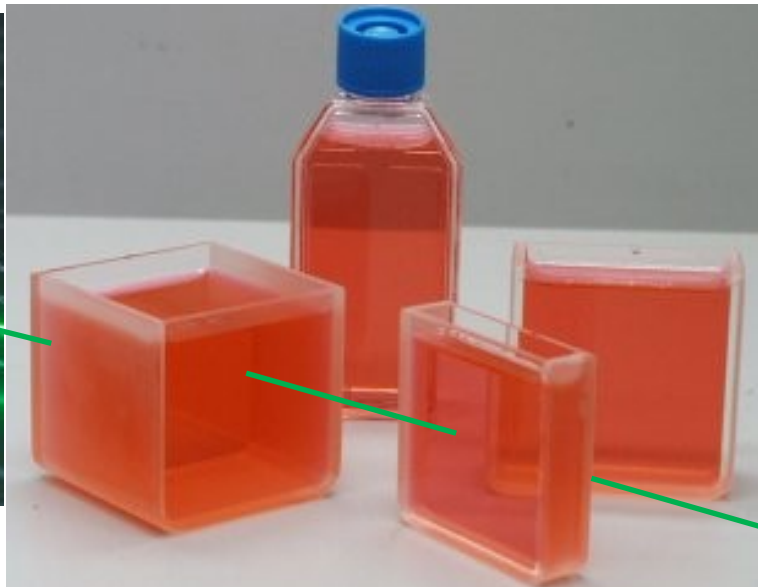
# Outline of the talk



- **Context**
- **Self-trapped beam technique**
  
- **Experimental demonstration**
- **Fabrication and test of index sensor**
- **Potential for integrated optics**
- **Conclusions.**

# Context

Analysis of liquid or gas properties using light



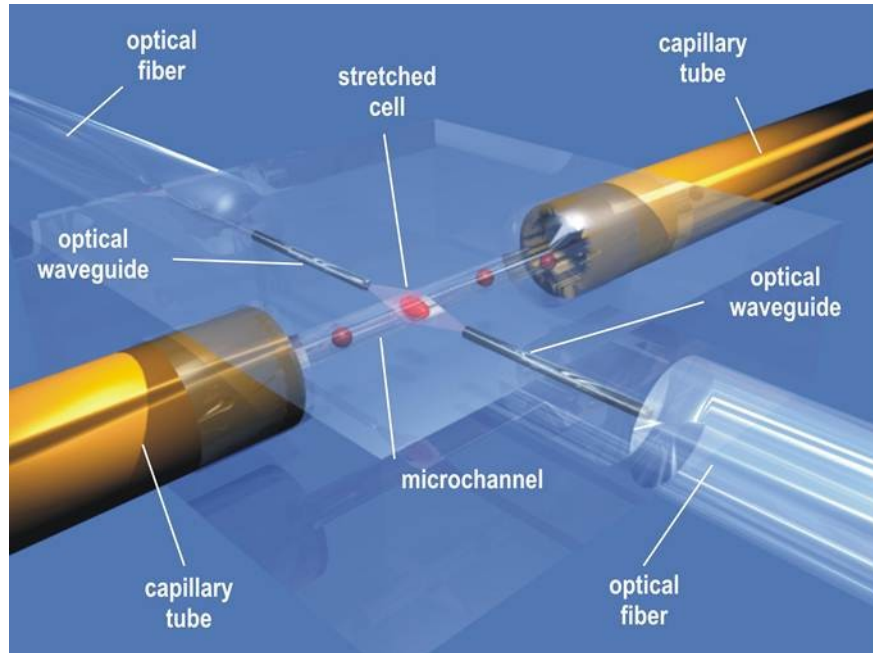
Available devices  
are often bulky



Great interest for fabrication  
of integrated devices

# Context

## Integrated optofluidic devices

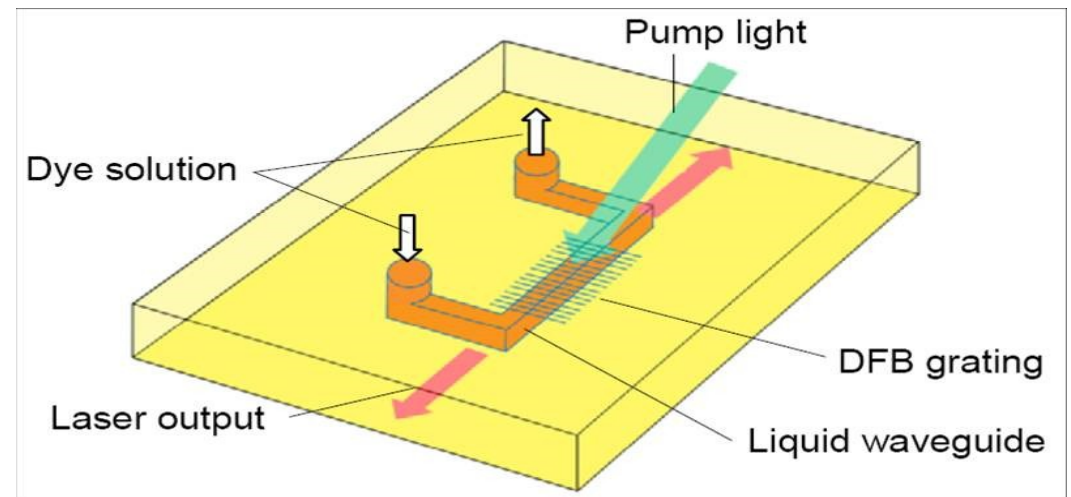


**Optofluidic chip for cell manipulation.** From : R. Osselame, Politecnico Di Milano.

### Interests :

- **Portable devices**
- **Fast response**
- **Very small quantity of analyte.**

**Domain of Interest : biology, chemistry, biomedical, integrated optics...**



**Optofluidic dye laser.** From : Li, Z. Y., Zhang, Z. Y., Emery, T., Scherer, A. & Psaltis, D., *Opt. Express* 14, 696–701 (2006).

# Context

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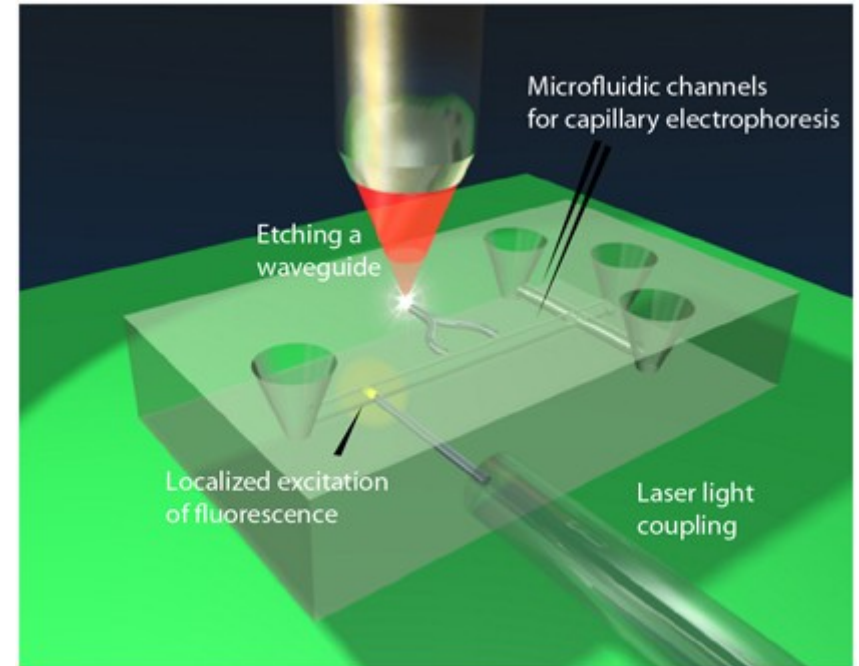
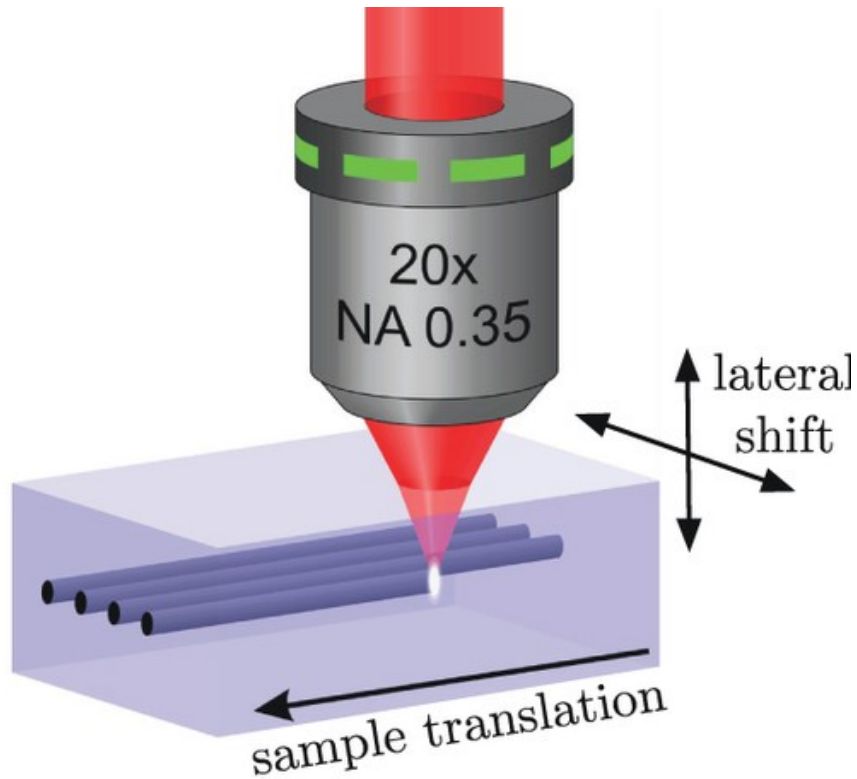


- Challenges : combination of micro-channels & optical waveguides :
  - Fluidic channels with smooth walls
  - Buried waveguides
  - Optimization of waveguides/channels alignment

# Fabrication technique



## Scanning beam technique



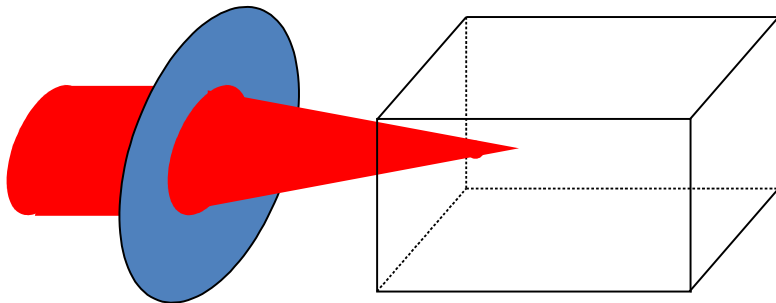
**Integrating optical sensing into lab-on-a-chip systems**, R. Osellame et. al. SPIE Newsroom, DOI: 10.1117/2.1200905.1597(1997)



# Fabrication technique

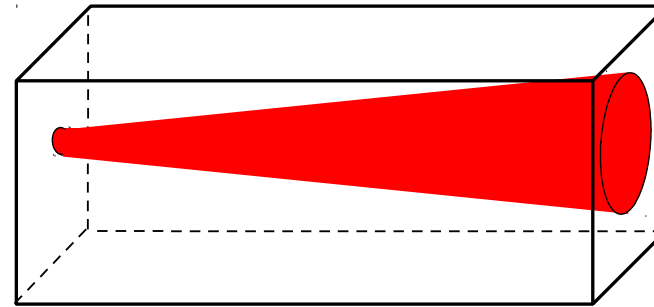


## Self-trapped beams



### **Self-trapped beam writing technique**

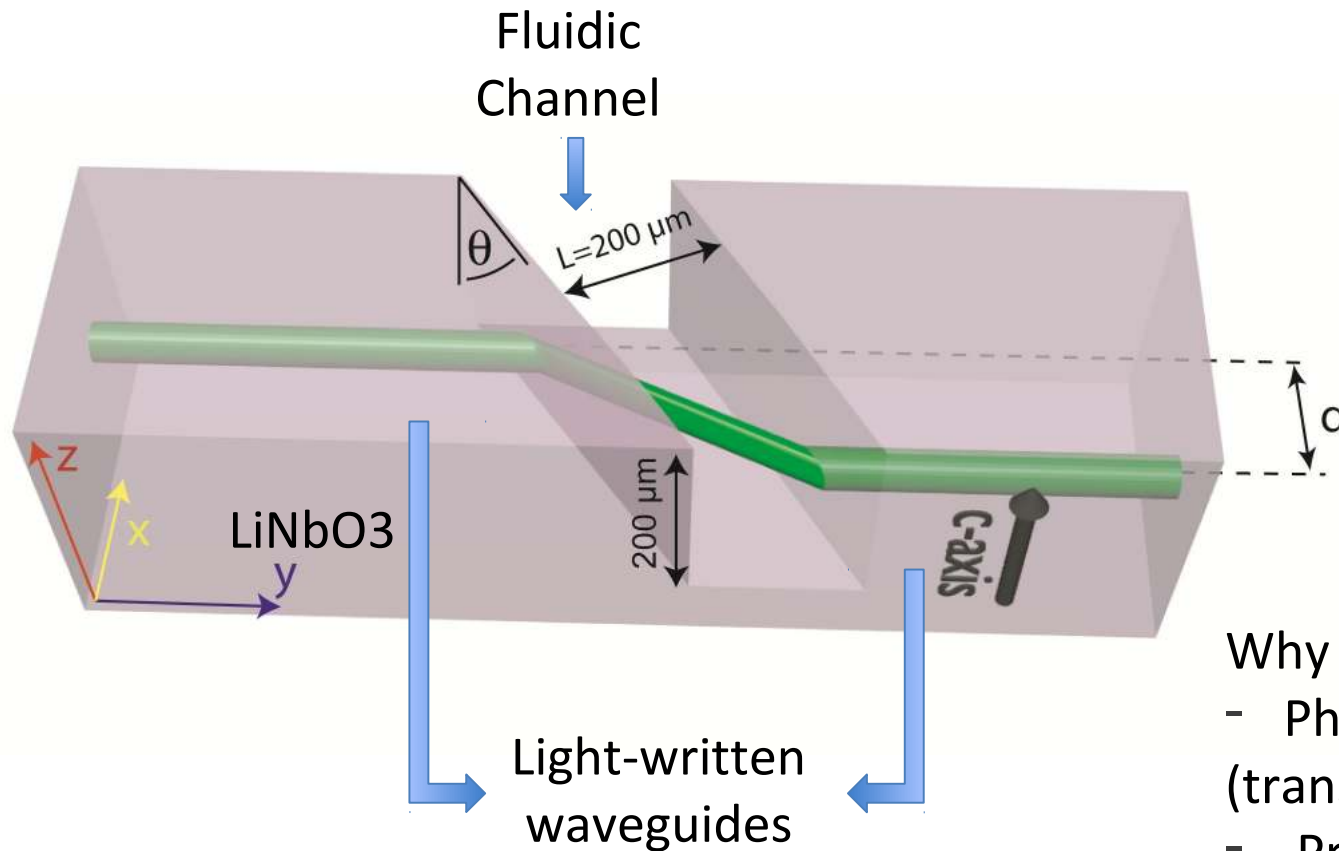
- Single step process
- Self-induced singlemode waveguides
- Low loss circular waveguides
- Self-aligned trajectory



### Requirements and characteristics

- Nonlinear focusing medium (Kerr, thermal, photopolymer, photorefractive..)
- Stable self-confinement of 2-D beams with saturable nonlinearity
- Ultimately spatial soliton can be formed

# Studied configuration



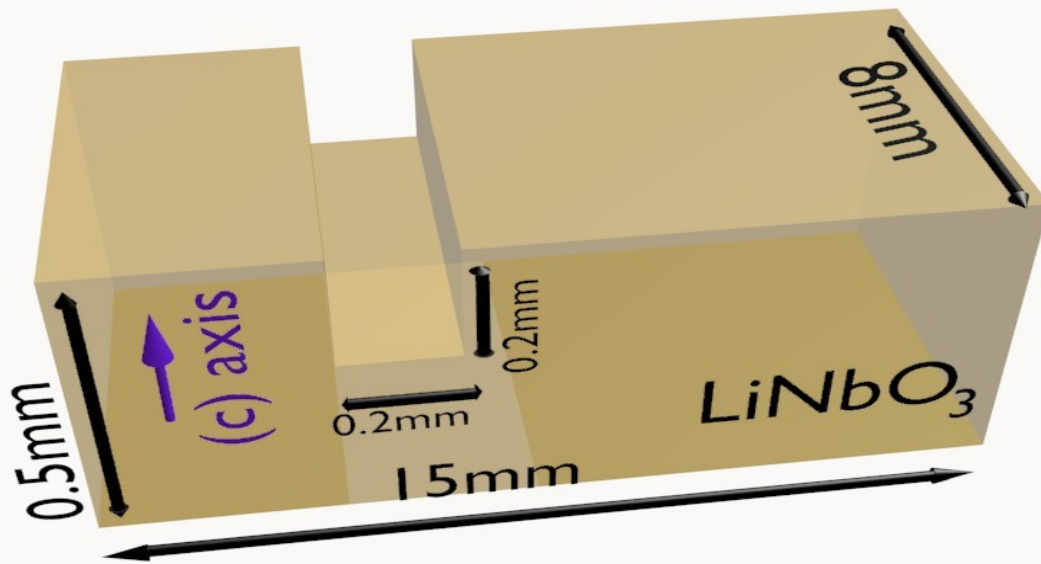
Why LiNbO3 ?

- Photonic material (transparent Vis-NIR, electro-optic, ..)
- Properties (photorefractive, pyroelectric, ..)



# Samples fabrication

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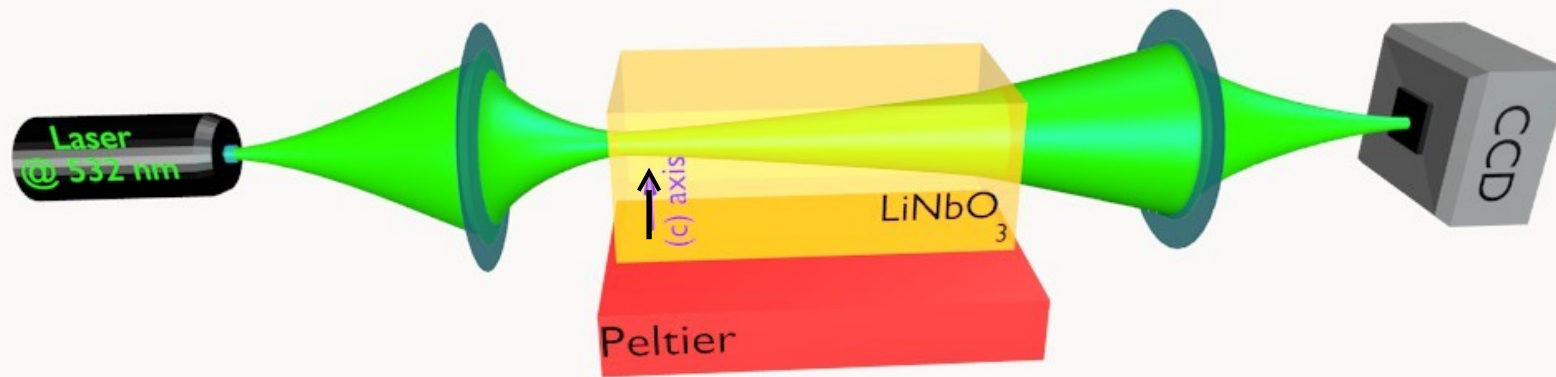


Precision saw Disco DAD 321

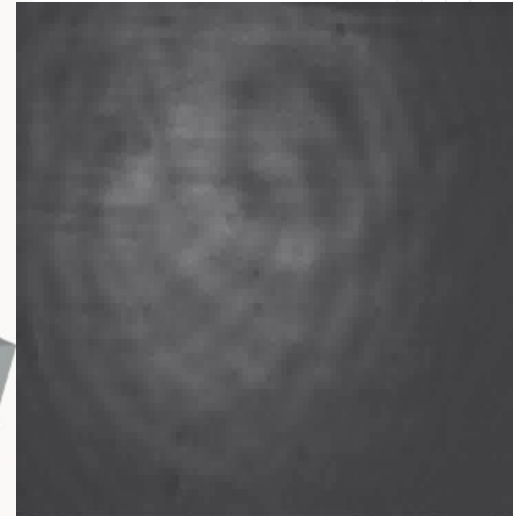
**Precision dicing/polishing is used to cut the sample and to inscribe the fluidic channel.**

# Waveguides induction : principle

## Optical set- up



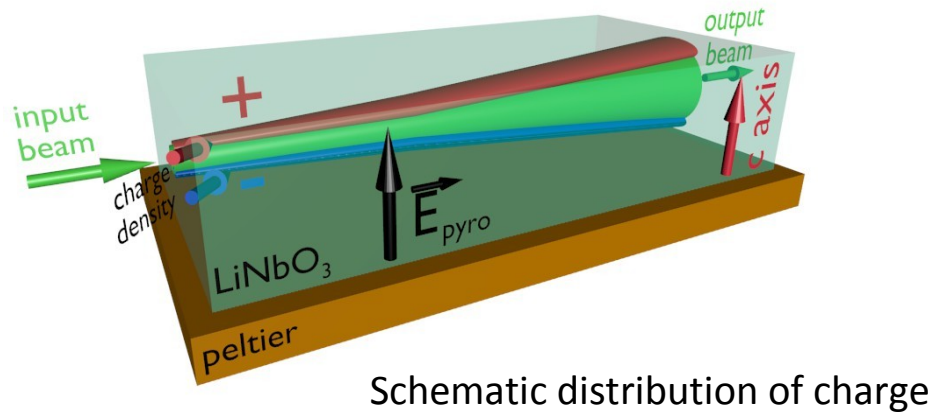
At room  
temperature



Experimental observation  
(15mm long crystal,  $\Delta T = 20^\circ\text{C}$ ,  
 $P = 200\mu\text{W}$ )

**The optical waveguide is induced by photorefractive beam self-trapping controlled by the pyroelectric effect.**

# Underlying physics

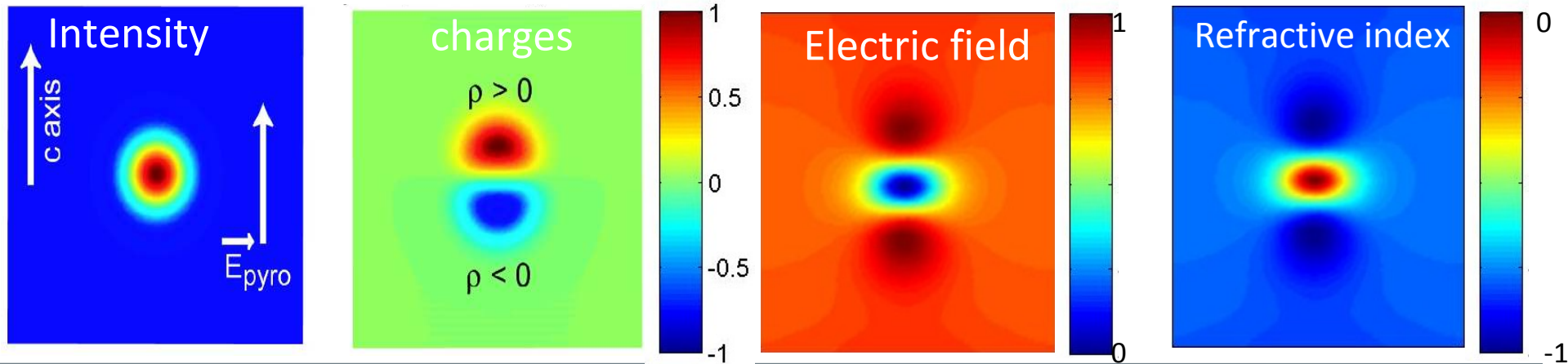


Pyroelectric field

$$E_{pyro} = \frac{-1}{\epsilon_0 \epsilon_r} p \Delta T$$

$$\Delta T = 20^\circ C \Rightarrow E_{pyro} \approx 42 \text{ kV} / \text{cm}$$

Normalized distributions

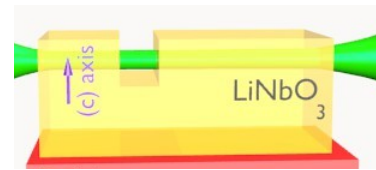
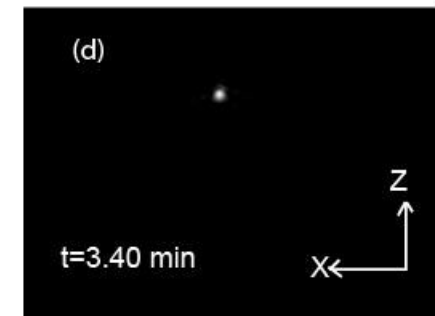
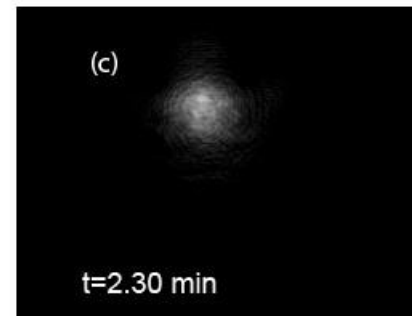
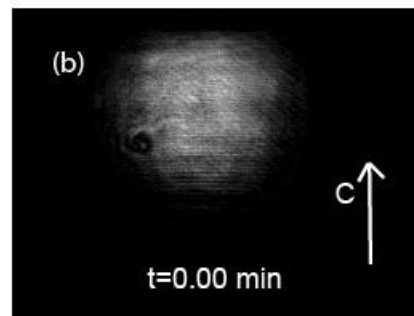


# Waveguide crossing channel ( $\theta=0$ )

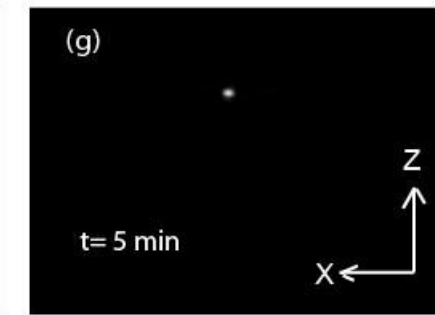
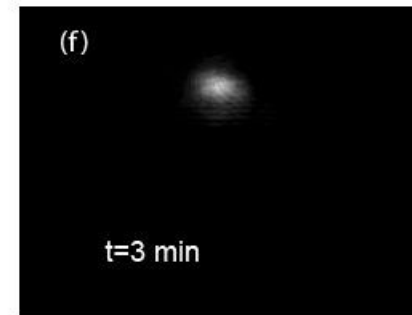
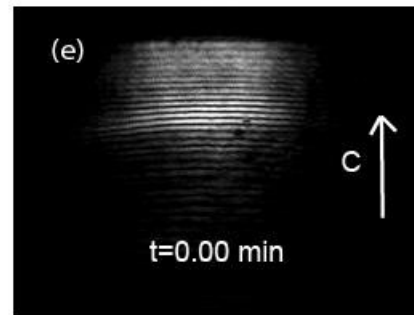
Input Beam  
(FWHM $\approx 10\mu\text{m}$ )



Without channel



With channel ( $\theta=0$ )



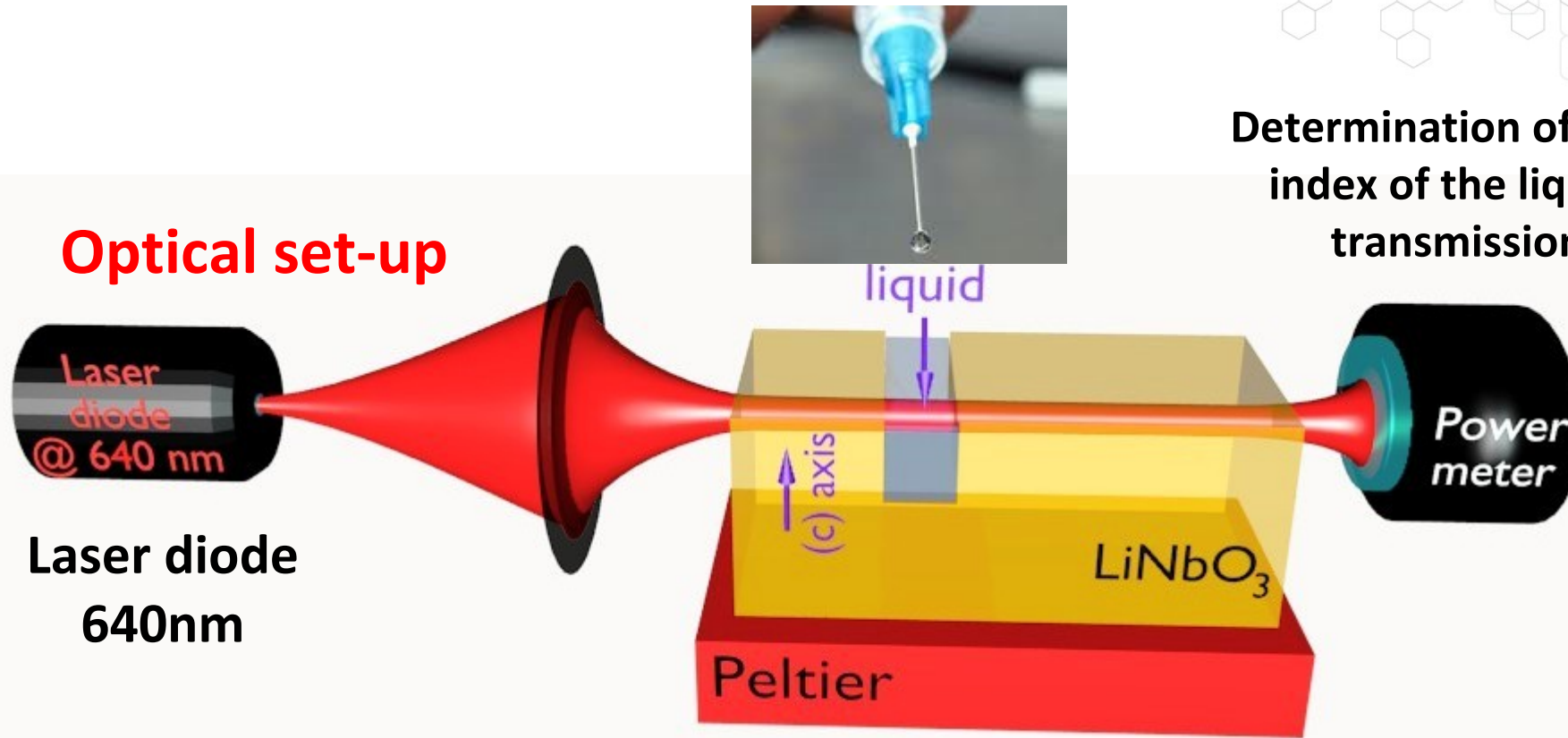
## Properties of induced waveguide :

- Singlemode
- Low losses (0.9dB)
- Quasi-permanent (lifetime > several months)

# Realization of an index sensor



## Optical set-up



Determination of the refractive index of the liquid ( $n_{liq}$ ) by transmission analysis

### Step 1 : waveguide induction

- No liquid
- Laser diode at high power
- Sample temperature = 40°C

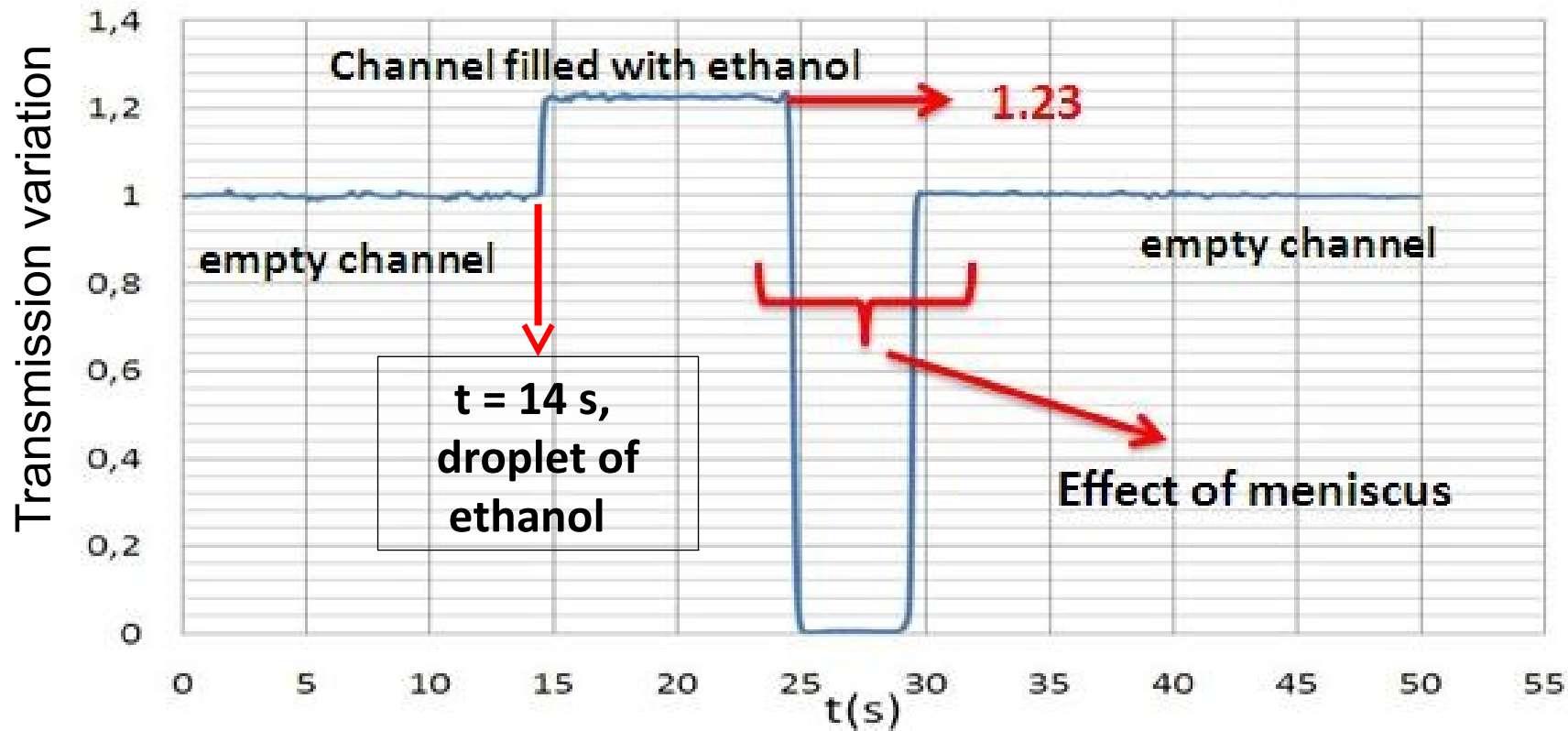
### Step 2 : index measurement

- Liquid present
- Laser diode current below threshold
- Sample at ambient temperature

# Test of index sensor



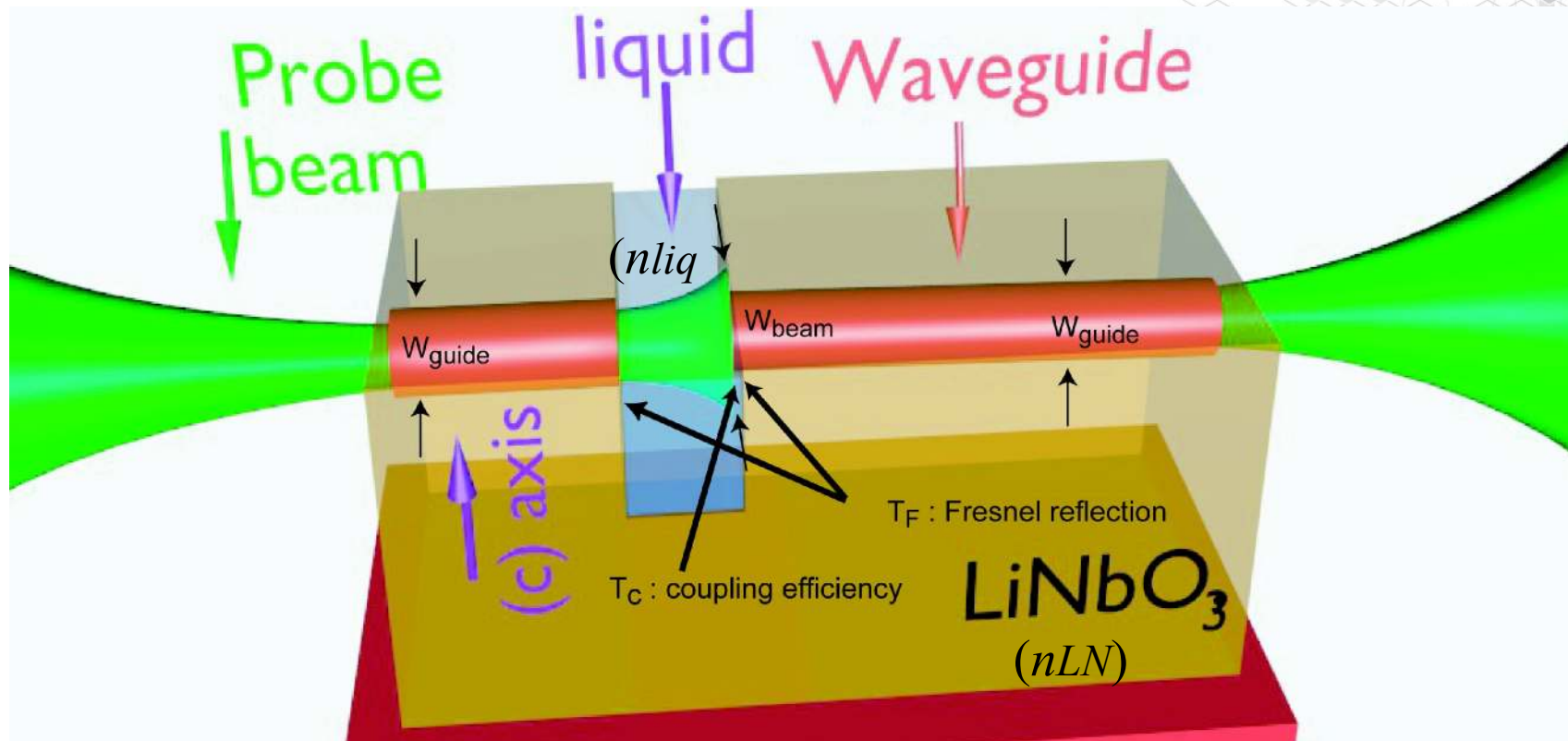
## Sensor response with ethanol



Evolution of the normalized sensor transmission versus time.



# Modeling of index sensor



Fresnel reflections :

$$T_F = \frac{2 n_{LN} n_{liq}}{n_{LN}^2 + n_{liq}^2}$$

Beam diffraction :

$$T_c = \frac{2 W_{guide} W_{beam}}{W_{guide}^2 + W_{beam}^2}$$

Total gap transmission :

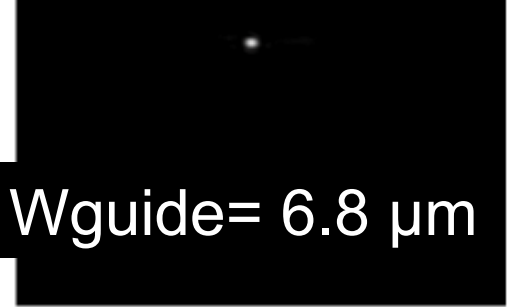
$$T = T_c \times T_F$$

$$W_{beam} = W_{guide} \sqrt{\frac{\lambda_0 L}{\pi n_{liq} W_{guide}^2}}$$

# Theoretical response of sensor

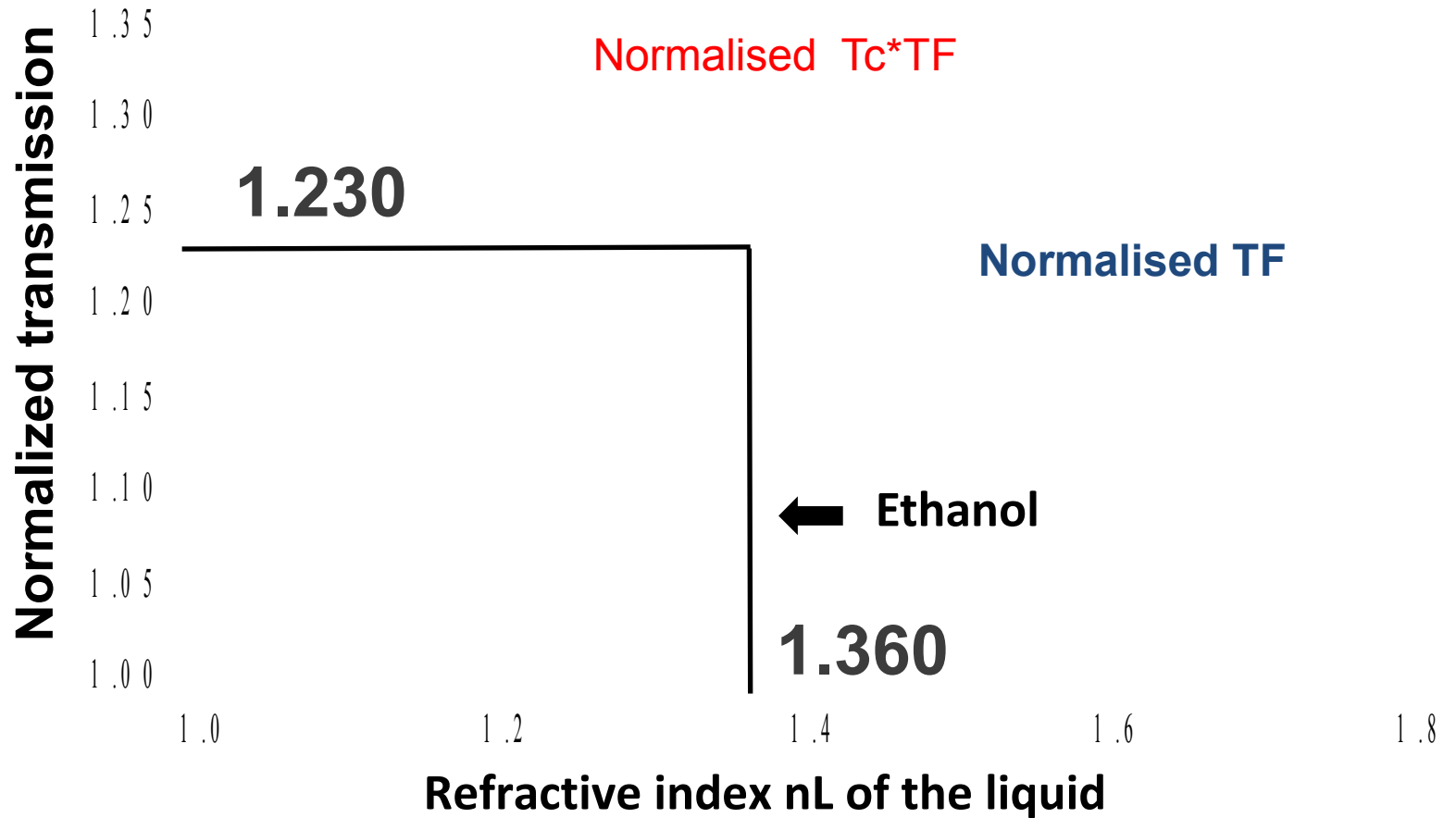


Image of guided mode

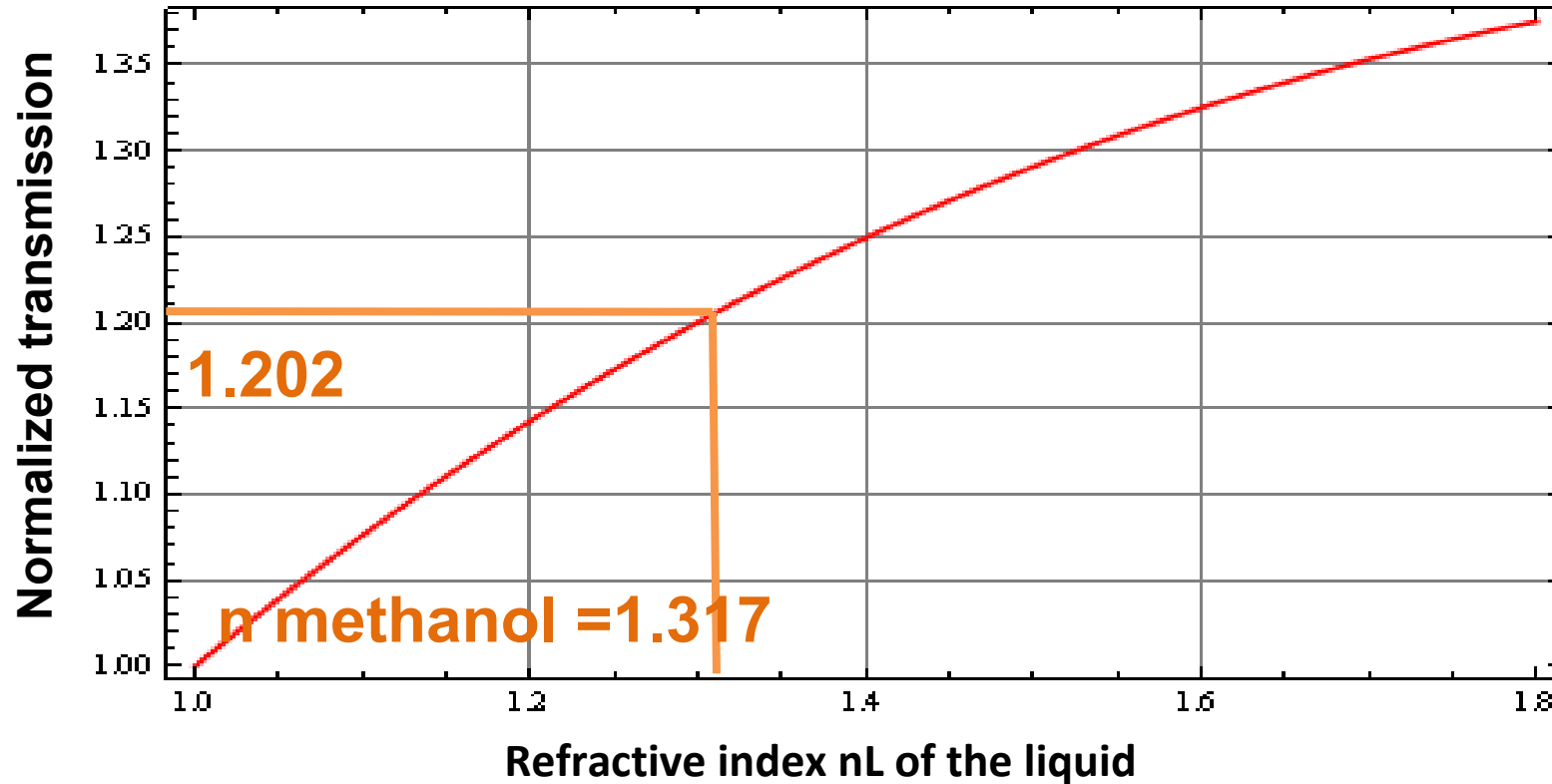
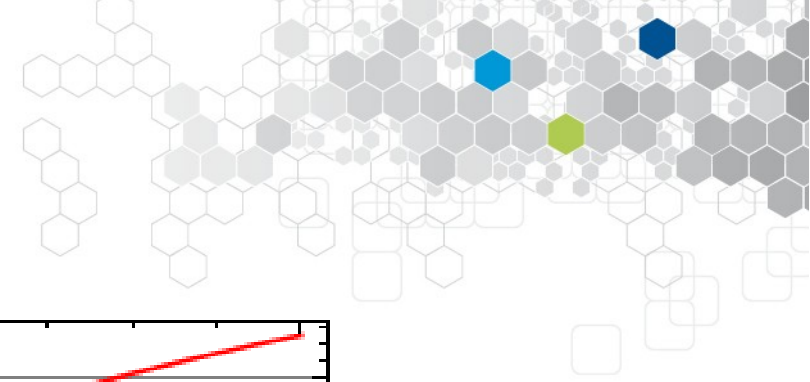


$W_{\text{guide}} = 6.8 \mu\text{m}$

Parameters :  
 $L = 200 \mu\text{m}$ ,  
 $\lambda_0 = 640 \text{nm}$ ,  
 $n_{LN}$  : Sellmeier equation.



# Measurement with methanol

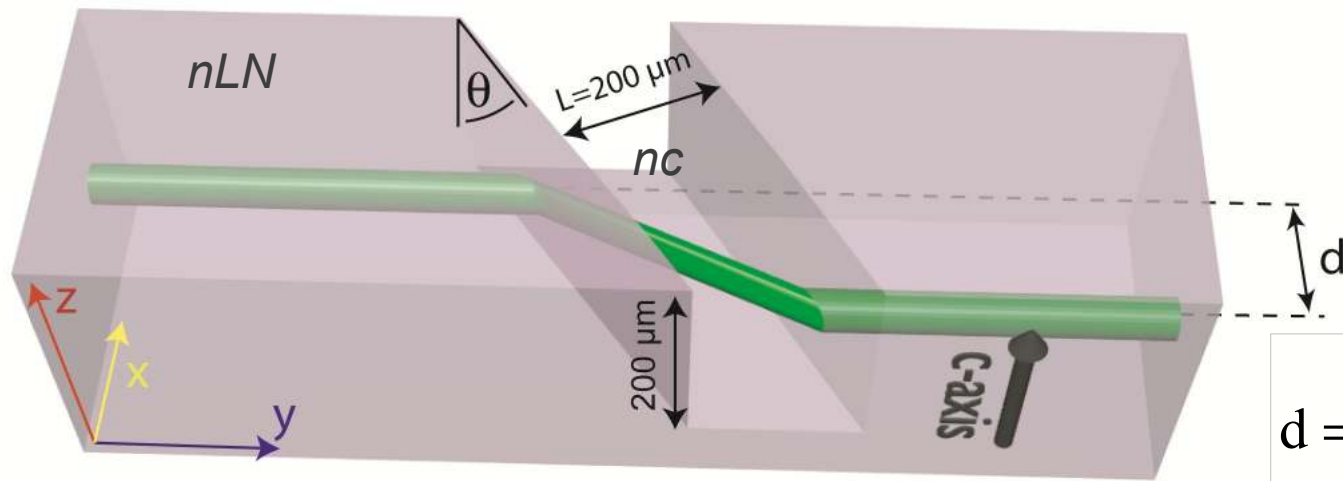


$$n_{\text{meth}}^{\text{exp}} = 1.317 \pm 0.005 \quad \longleftrightarrow \quad n^{\text{theo}} = 1.320$$

# Tilted channels ( $\theta \neq 0$ )



Interest : high sensitivity sensors, innovative integrated optics ..

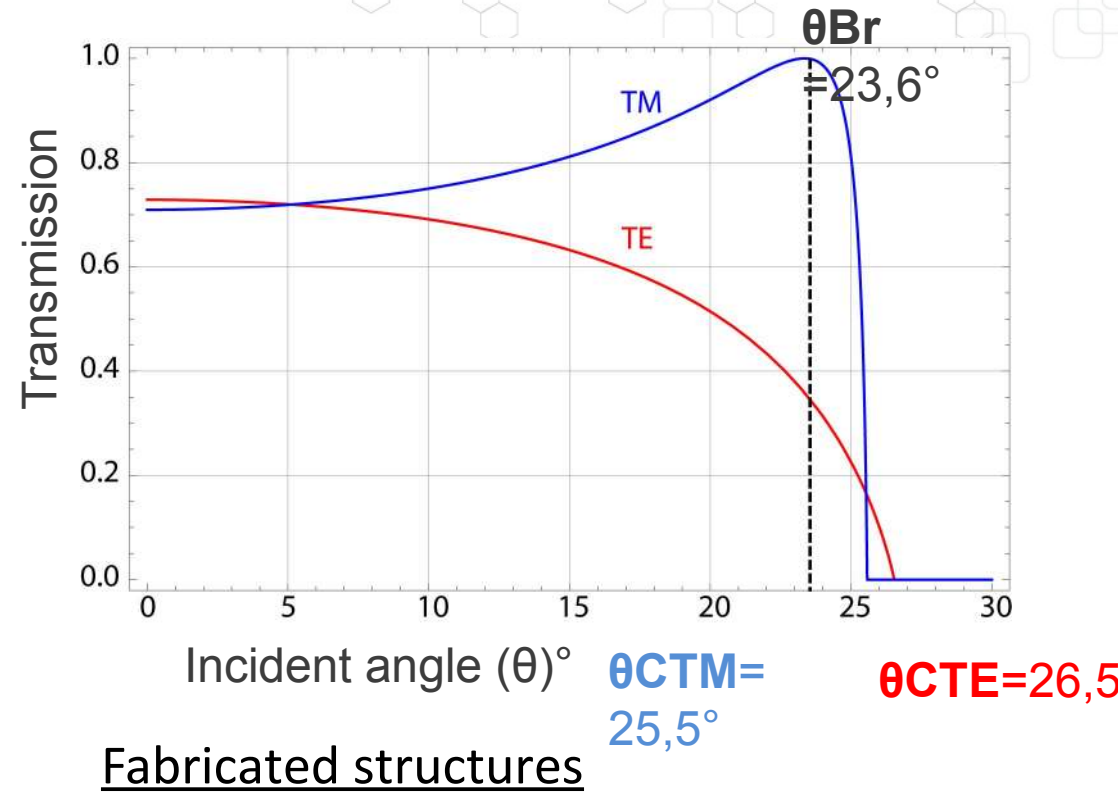
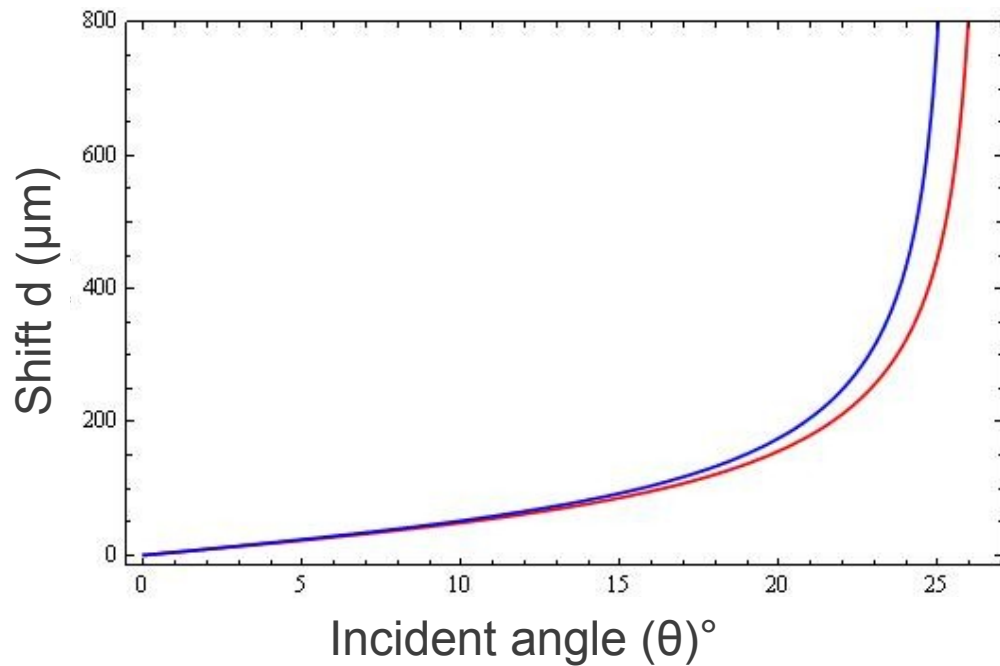
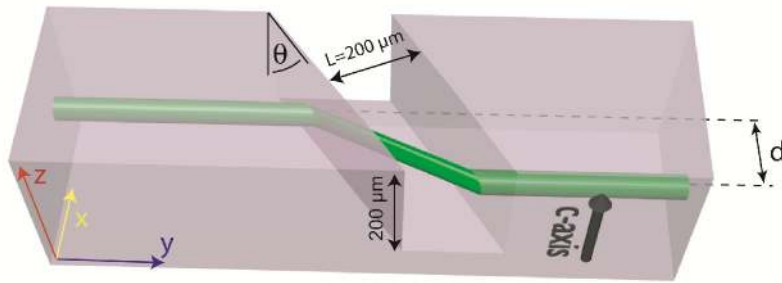


$$d = L \tan \left( \arcsin \left( \frac{n_{LN}}{n_c} \sin \theta \right) \right)$$

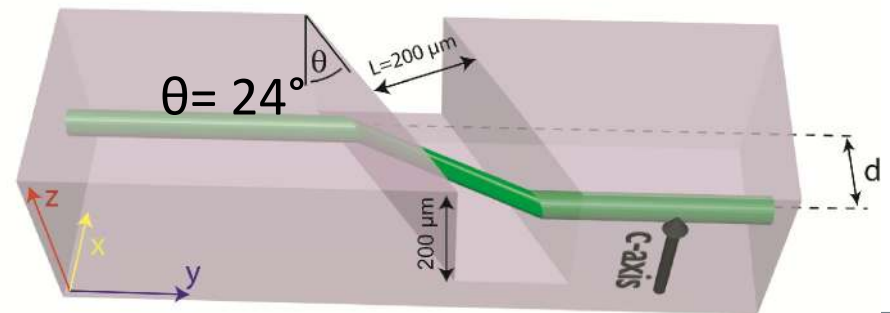
When incident angle  $\theta$  approach the critical angle

- Beam shift  $d$
- Beam distortion
- Beam transmission  $T$

# Influence of channel tilt angle



Fabricated structures



# Experimental results



Parameters :

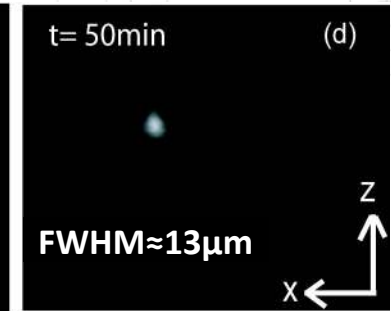
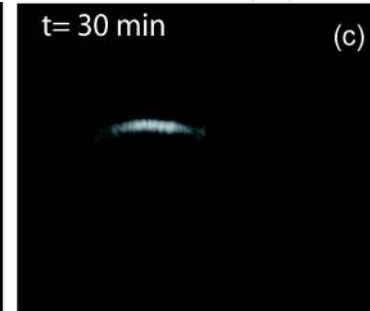
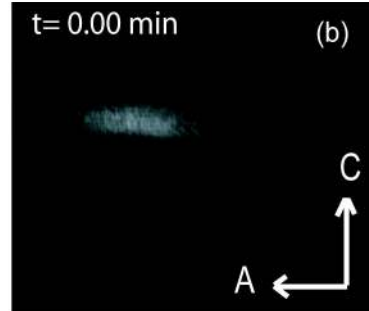
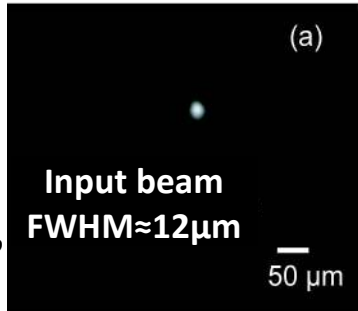
$\lambda = 532\text{nm}$ ,

ordinary

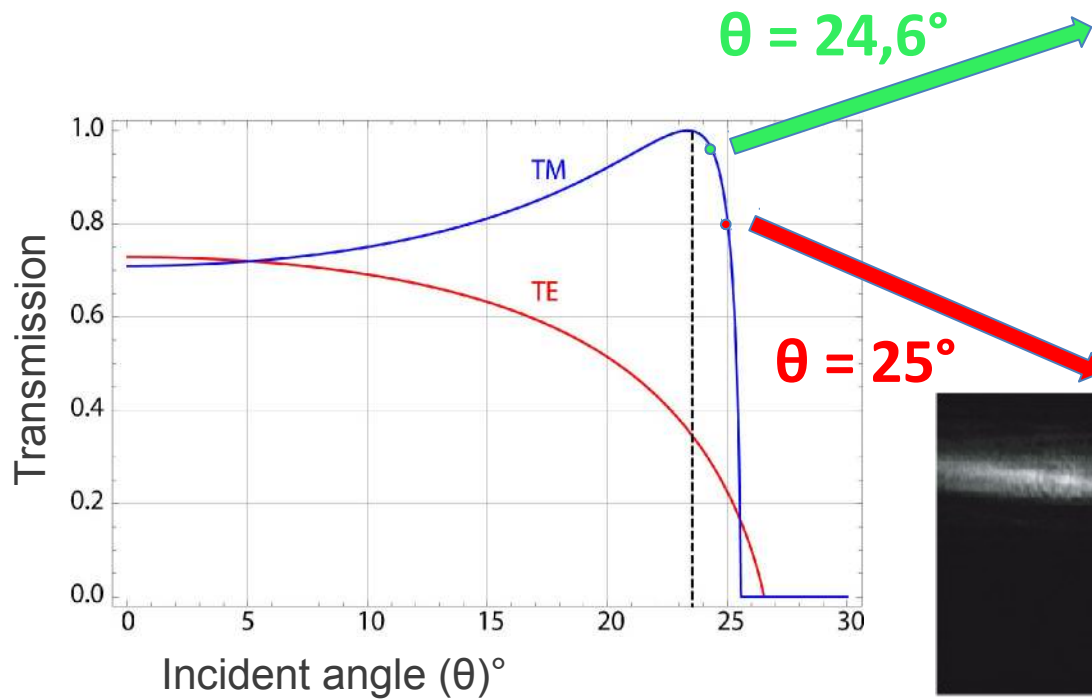
polarization

(TM),  $P = 20\mu\text{W}$ ,

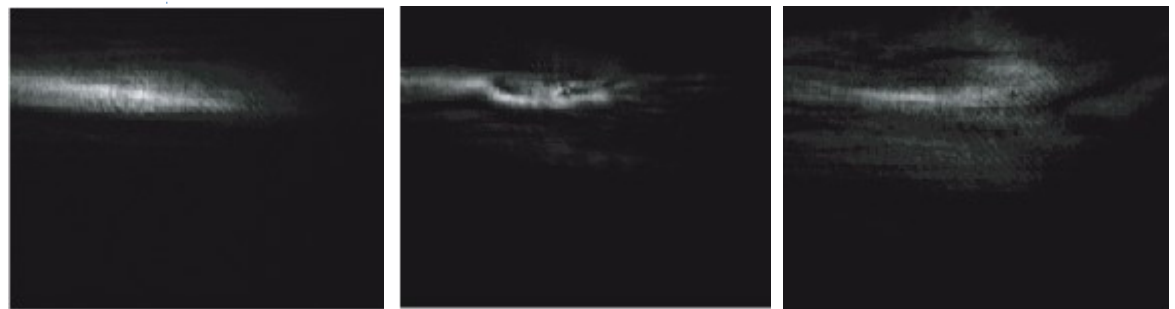
$\Delta T = 20^\circ\text{C}$



Successful self-trapping

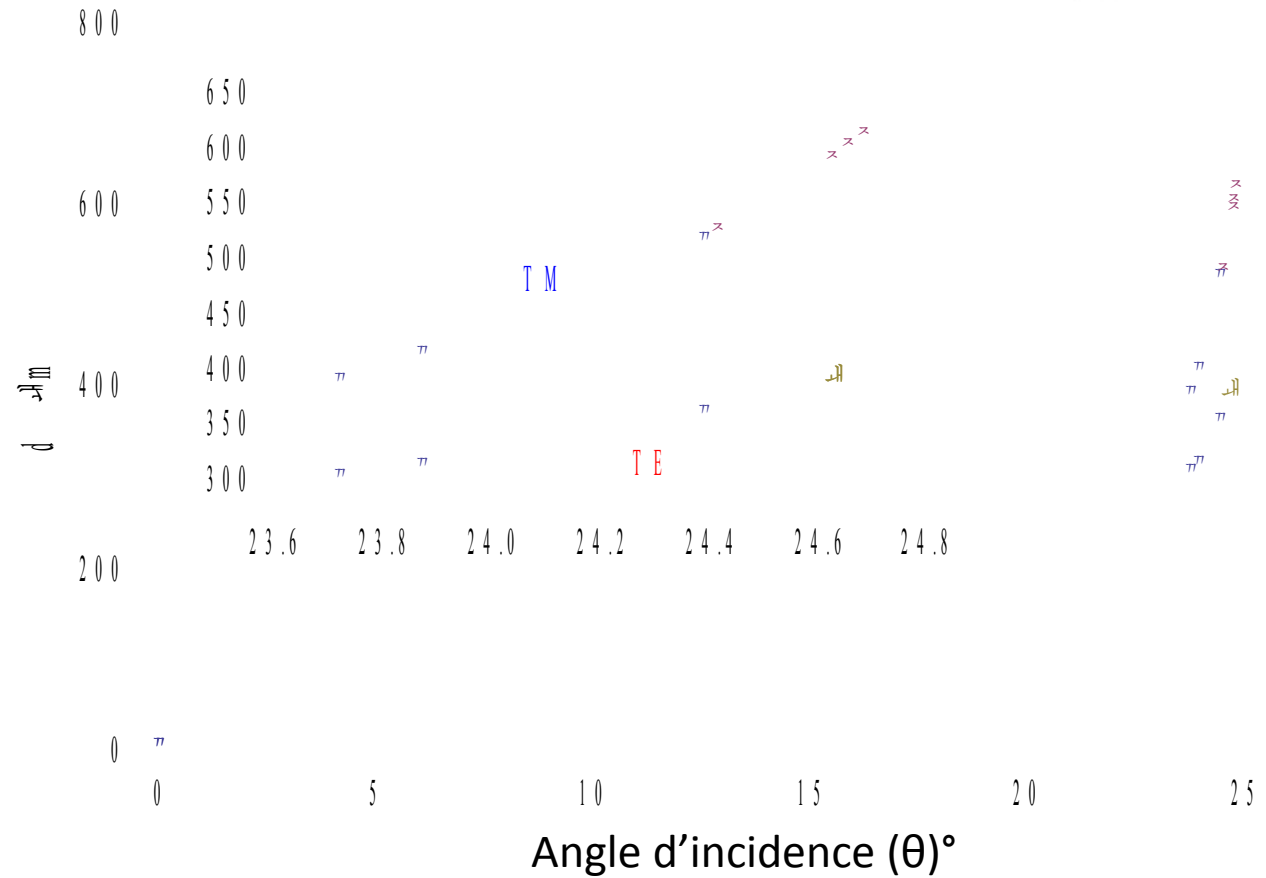
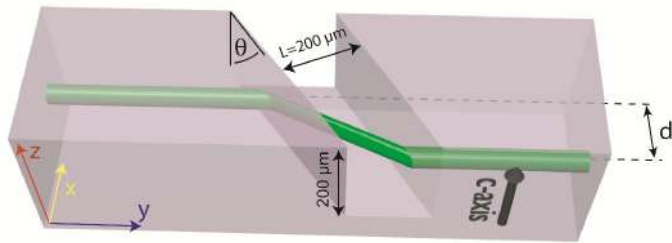


Unsuccessful self-trapping



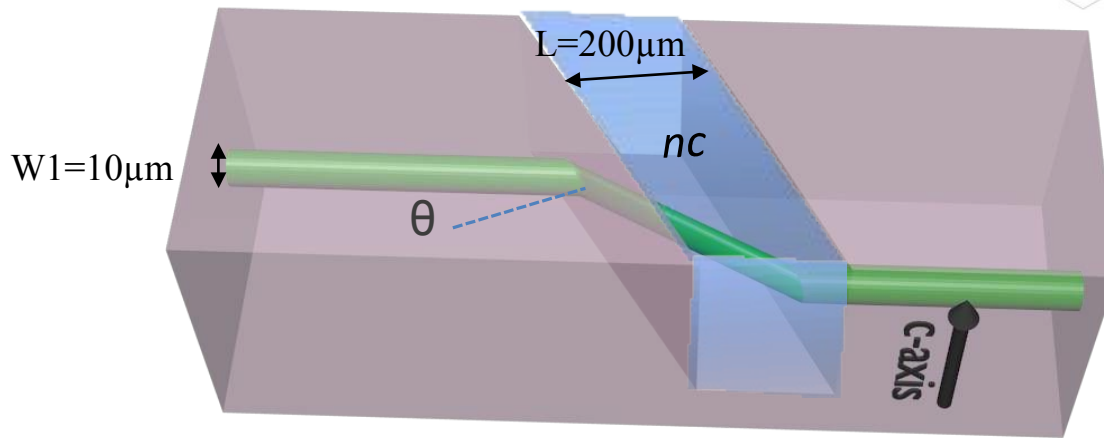


# Experimental results



**Beam self-focusing is obtained for both TE and TM polarizations for incident angle close to critical angle**

# Potential for sensing devices

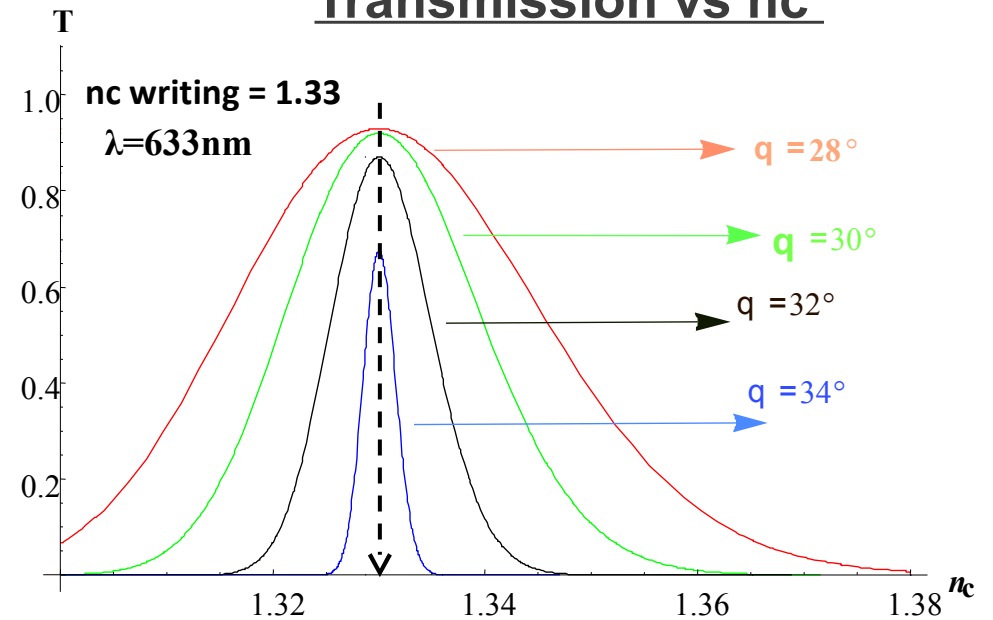


**Fabrication :**  
Waveguide written  
with ref. liquid

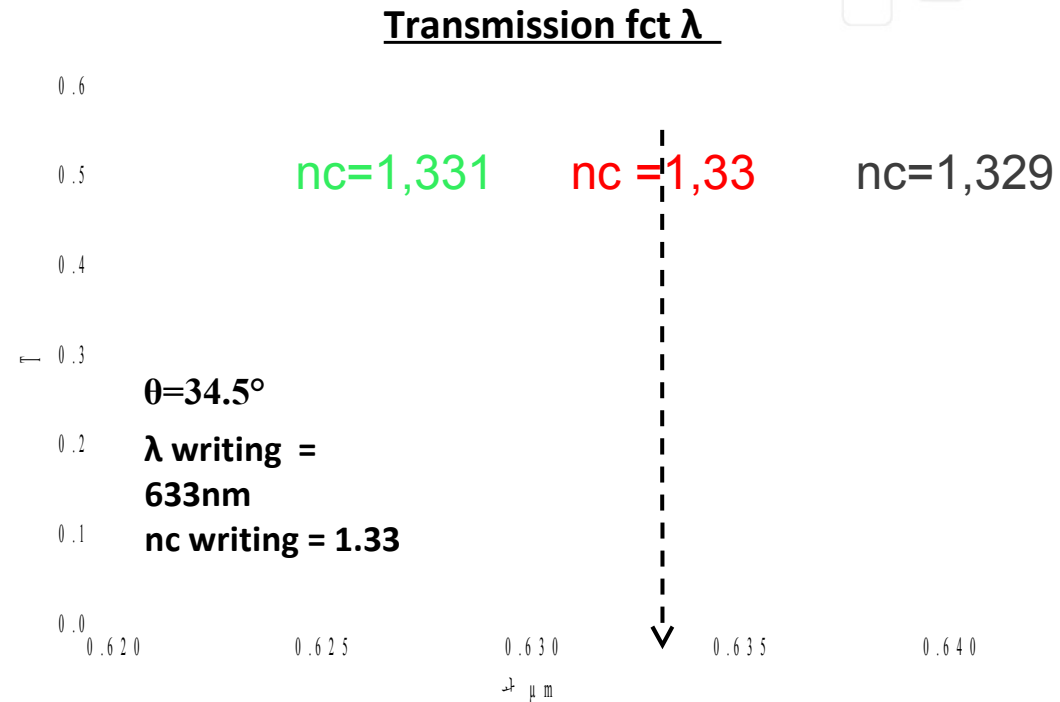
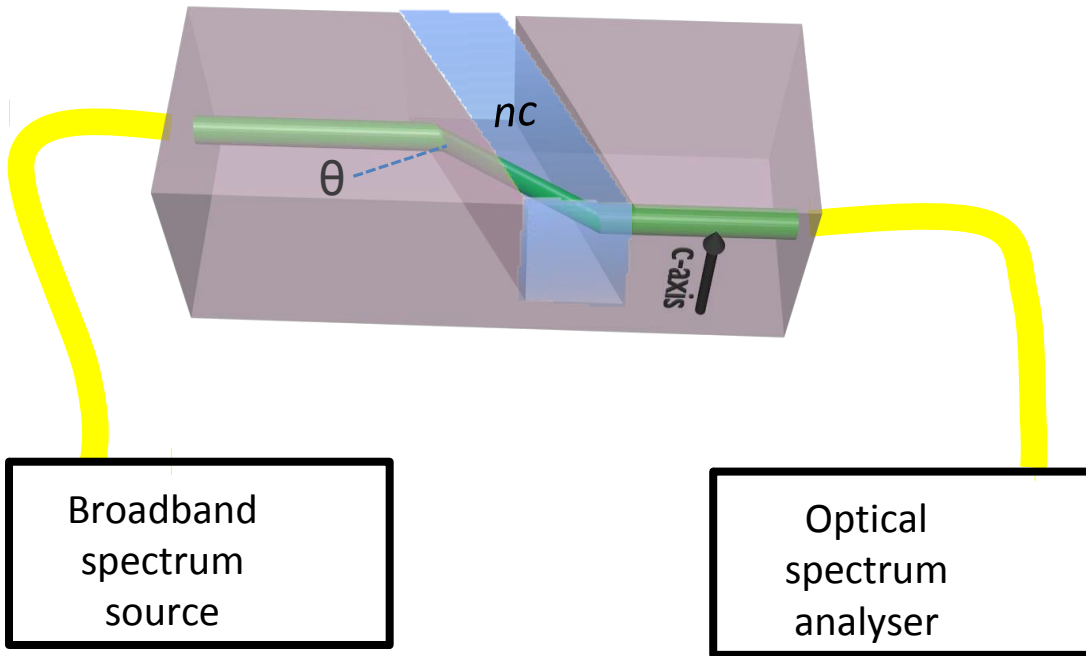
**Use :** Transmission  
highly dependent on  
test liquids index

Sensor  
sensitivity and  
span can be  
adjusted with  $\theta$   
value

## Transmission vs $n_c$



# Potential for sensing devices/spectral filters



## Index sensor

$$\frac{dn_c}{d\lambda} \approx 10^{-4} / nm$$



Sensitivity can reach 10-6

## Spectral filter

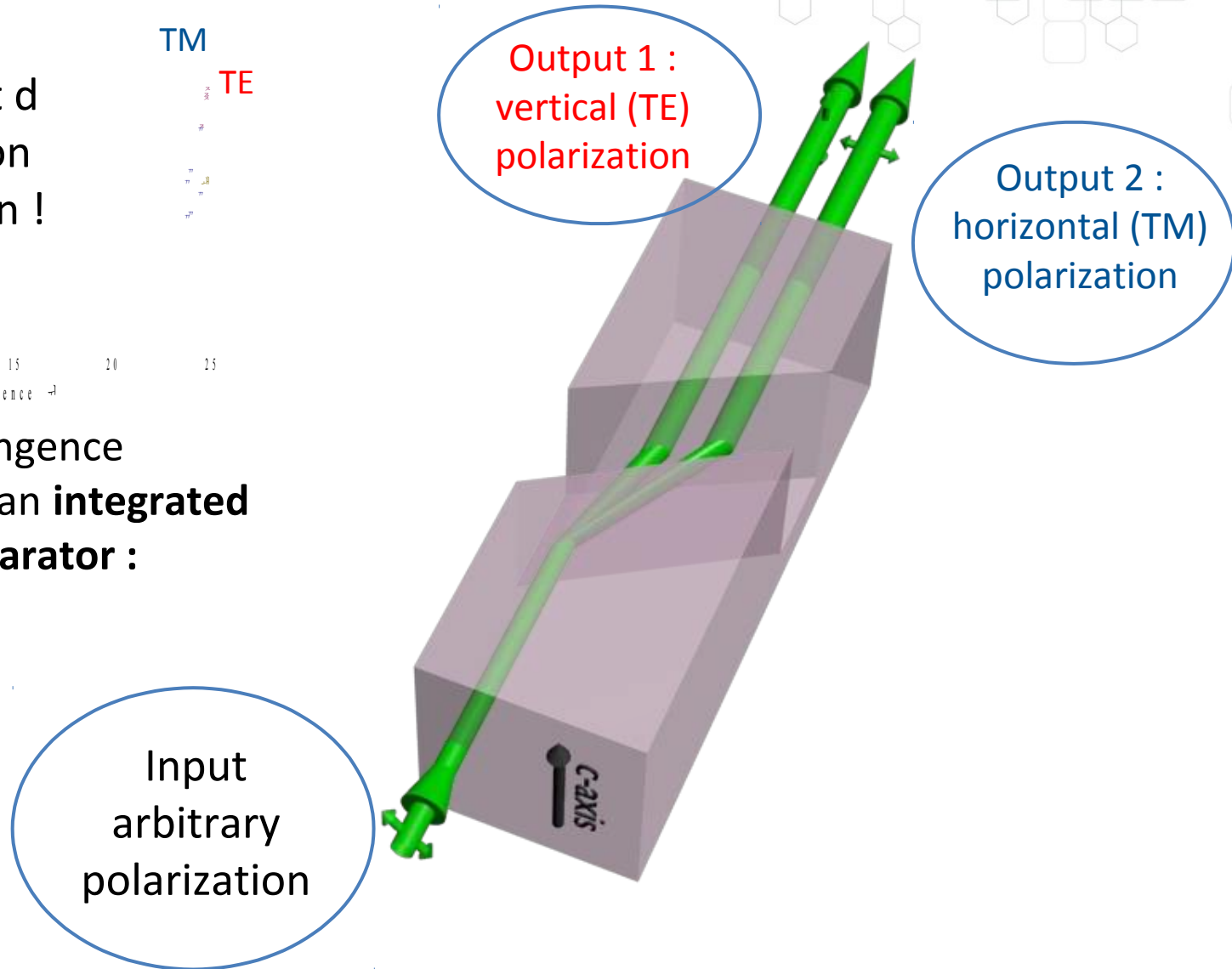
- Spectral width adjustable with  $\theta$
- Central wavelength tunable with fluid

# Potential for integrated optical components



Beam shift  $d$  depends on polarization !

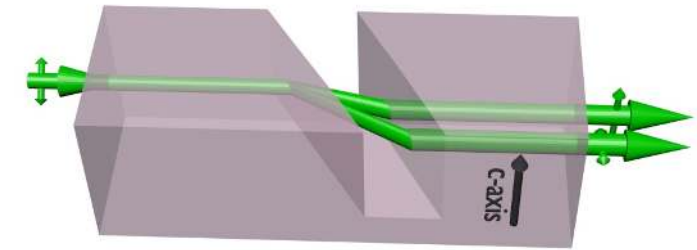
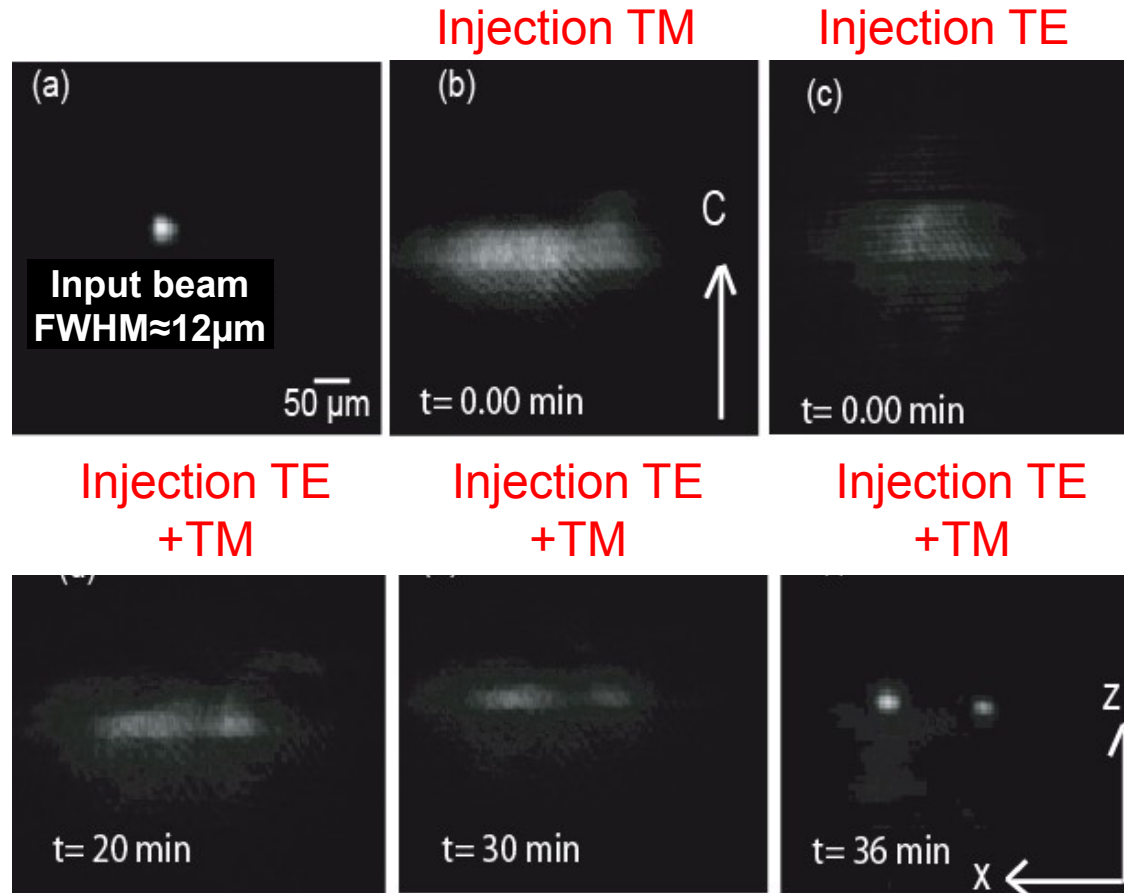
Material birefringence can be used to design an **integrated polarization separator** :



# Fabrication of a polarization separator



Parameters :  
 $\lambda = 532\text{nm}$ ,  
 $P = 20\mu\text{W}$ ,  
 $\theta = 23.9^\circ$   
 $\Delta T = 20^\circ\text{C}$



The polarization separator is inscribed in a one step self-writing process.

# Test of polarization separator



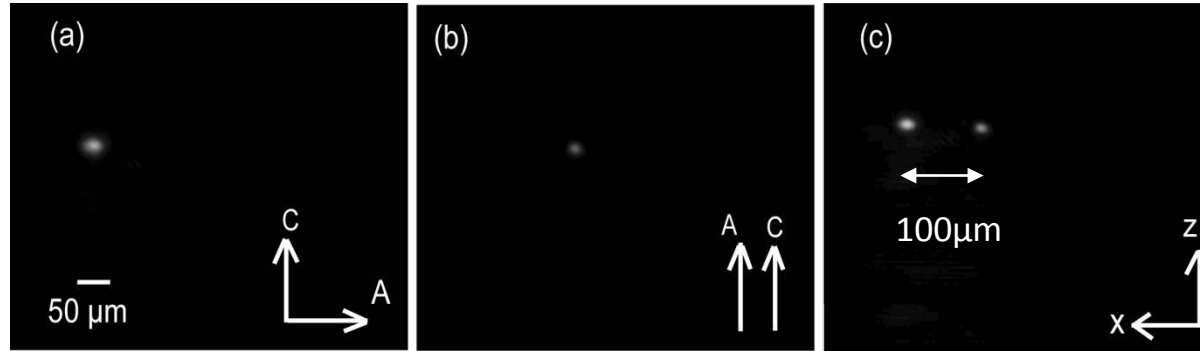
Input polarization

TM

TE

TM+TE

Detected intensity



## Properties of component :

- Extinction ratio TE/TM > 20db
- Transmission 68% for TM et 25% for TE



# Conclusions

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- ❑ Ability of self-trapped beams to induce unique automatically adapted buried waveguides crossing channels have been demonstrated
- ❑ Integrated components based on LiNbO<sub>3</sub> have been fabricated
  - Index sensor
  - Integrated polarization separator

# Perspectives

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- ❑ More elaborated devices taking advantage of self-aligned waveguides can be developed :
  - High sensitivity sensors, tunable filters, couplers to optical resonators
- ❑ Use of other materials such as photopolymers (low cost and permanent structuring)